



EXPEDITED PROCEDURE – EXAMINING GROUP 2815

#19/F(VE)
Amended by
Y. Robinson
PATENT 5/22/03

IN 09/259762

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Zhiping Yin et al.

Examiner: Jose Diaz

Serial No.: 09/259762

Group Art Unit: 2815

Filed: March 1, 1999

Docket No.: 303.531US1

Title: OXYGEN PLASMA TREATMENT FOR NITRIDE SURFACE TO REDUCE PHOTO
FOOTING

AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O.Box 1450
Alexandria, VA 22313-1450

In response to the Final Office Action mailed March 10, 2003, please amend the
application as follows:

RECEIVED
MAY 19 2003
TECHNOLOGY CENTER 2800